PTO-1449			Attorney's Docket Number 128834-1		Serial Number 10/638,094		
INFORMATI	ON DISCLOSURE STATEMENT B	Name of Applicant Borst et al.					
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Examiner Initial	Document Number	Date	NAME	Class	Subclass	Filing Date If Appropriate	
4	4942073	6/17/1990	Era et al.				
	5118573	6/2/1992	Tawara et al.				
	5297132	3/22/1994	Takano et al.				
	5330852	7/19/1994	Gerstenberg et al.				
4	5525379	6/11/1996	Takada et al.				
U.S. PATENT APPLICATION PUBLICATIONS							
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FOREIGN PATENT DOCUMENTS Examiner Date COUNTRY Class Subclass TRANSLATION							
Examiner Initial	Document Number	Date	COUNTRY	Class	Subclass	YES NO	
			11 41 431 44 4 4				
OTHER INFORMATION (including author, title, date, pertinent)							
LX	Y.Barrell et al., "Expanding Thermal Plasma for Fast Deposition of Scratch-Resistant SiCxHyOz Films", Surface and Coatings Technology 180-181 (2004) 367-371						
Lx	M.F.A.M. van Hest doctoral thesis, "High Rate Deposition of Silicone Oxide Like Films" pages 95-108, 133-154, 167-169 (2002)						
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.							